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SHEET 1 OF 1

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8674.023.US0000APPLICATION NO.
10/516,888INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

(Use several sheets if necessary)

APPLICANT
Paul Alexander DE VRIES et al.FILING DATE
December 3, 2004GROUP
1793

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Notice of Allowance, March 18, 2008, for US Patent Appln. No. 10/488,042 to DeVries
	Office Action, May 11, 2007, for US Patent Appln. No. 10/488,042 to DeVries
	Office Action, October 16, 2007, for US Patent Appln. No. 10/488,042 to DeVries
	Office Action, December 3, 2007, for US Patent Appln. No. 10/491,278 to DeVries
	Office Action, June 26, 2007, for US Patent Appln. No. 10/491,278 to DeVries
	Office Action, August 30, 2007, for US Patent Appln. No. 10/516,889 to DeVries et al.
	Office Action, January 31, 2008, for US Patent Appln. No. 10/516,889 to DeVries et al.
	Hanumanth et al., "Particle Sedimentation During Processing of Liquid Metal-Matrix Composites", Metallurgical Transaction B., Vol. 23B, pp. 753-763 (1992)
	L.C. Bartel et al., "An Electrical Resistivity Measurement in Molten Basalt During the 1983 Kilauea Eruption, Bull. Volcanol., Vol. 46.3, pp. 271-276 (1983)

EXAMINER

/Tima Mcguthry Banks/ (04/14/2009)

DATE CONSIDERED

EXAMINER: Initial if citation is considered, draw line through citation if not in conformance and not considered.
Include copy of this form with next communication to applicant.

(Form PTO-1449 [6-4])

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /T.M./